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09/902607

	Class	Subclass

PATENT NUMBER

U.S. UTILITY Patent Application

O.I.P.E.		PATENT DATE
SCANNED	FC3	O.A. 4A

APPLICATION NO. 09/902607	CONT/PRIOR F	CLASS 257 53	SUBCLASS 13	ART UNIT 2811	EXAMINER THOMAS FREY
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SEMICONDUCTOR DEVICE HAVING THIN FILM FORMED BY ATOMIC LAYER DEPOSITION AND METHOD FOR FABRICATING THE SAME

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PTO-2040
12/99

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